

Notice of References Cited	Application/Control No. 10/605,078	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Tammy Pham	Art Unit 2675	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0135738	07-2004	Kim et al.	345/001.1
*	B	US-2003/0025677	02-2003	Iwamoto et al.	345/173
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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